Title: METHOD OF SELECTIVE REMOVAL OF SiGE ALLOYS
Inventors: Hammond et al.
Express Mail Label No. EV334229294US
Atty Docket No.: ASC-057C1
Attorney for Applicants: Mark L. Beloborodov
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10

E Si LAP	
Sibe	18
E Si	~16
relaxed sibe	14
Si Substrate	-12

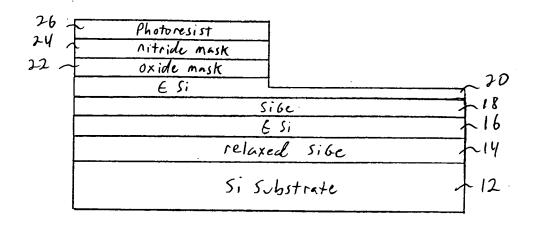
F16.1

Photo resist	
nitride mask	
Oxide mask	
E Si Cap	
Sibe	
<u> </u>	
relaxed sibe	
Si Substrate	

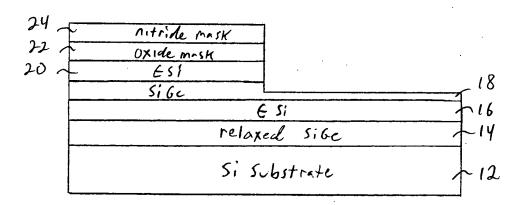
F16.2

Title: METHOD OF SELECTIVE REMOVAL OF SIGE

ALLOYS
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F16.3

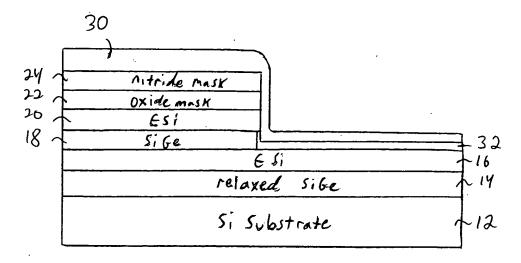


F16.4

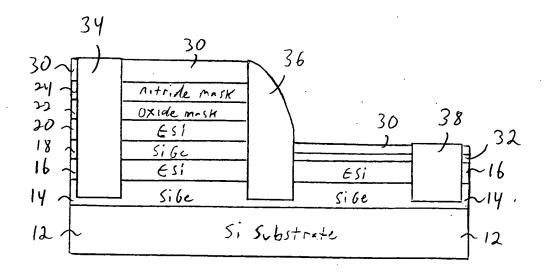
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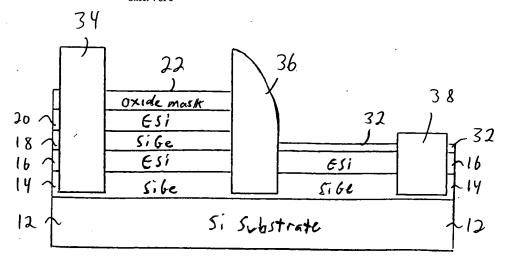


F16.5

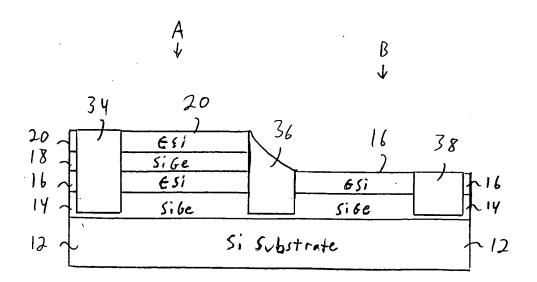


F16.6

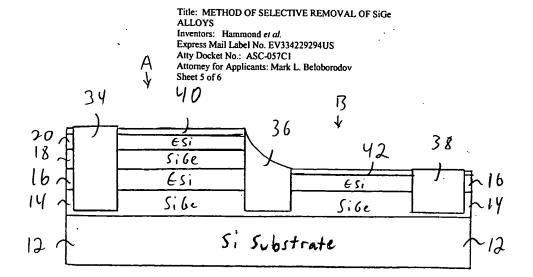
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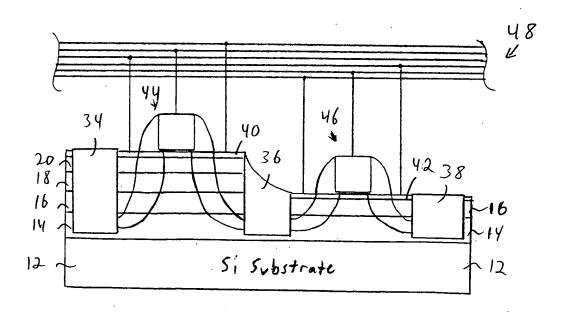
F16.7



F16.8



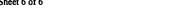
F16.9

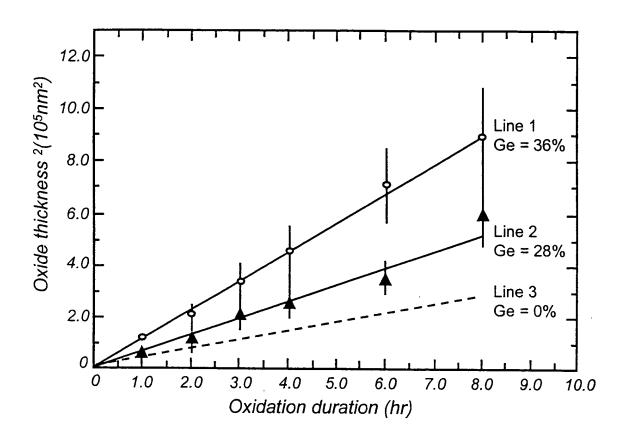


F16.10

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